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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Comple	te if Known	
Application Number	10/817,133	
Filing Date	April 1, 2004	
First Named Inventor	WOODS et al.	_
Art Unit	1746	_
Examiner Name	Unassigned	
Attorney Docket Number	LAM2P475	

U.S. Patent Documents

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Examiner	Cite No. ¹	Document Number	Publication	Name of Patentee or	Pages, Columns, Lines, where Relevant	
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13M2	М	EP 1 489 461 A1	12/22/04	ASML Netherlands B.V.		
W6	N	EP 1 489 462 A2	12/22/04	ASML Holding N.V.		

Non Patent Literature Documents

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Examiner Initial	Cite No.	Include name of author (in CAPTIAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published			
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Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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